

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Attorney Docket No.: 47233-0044-00-US	Serial No.: 10/507,127
	Applicants Keiichi ABE et al.	Page 1 of 1
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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS

(Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)		
/LT/	ISHIKAWA et al., "Thin-Layer Chromatography – Basis and Applications," December 10, 1963, pp 9-11, Nanzando Co., Ltd., Japan (partial translation)	

Examiner /Lien Tran / (10/14/2008)	Date Considered 10/14/2008
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